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3/28/05

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Akihiko OTOGURO et al.**

Group Art Unit: **2822**

Serial No.: **10/603,077**

Examiner: **Christy L. Novacek**

Filed: **June 25, 2003**

Confirmation No.: **1877**

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND
METHOD OF FORMING PATTERN**

Attorney Docket Number: **030757**
Customer Number: **38834**

RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCESSING REQUESTED

BOX AF

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Date: March 28, 2005

Sir:

In response to the Office Action dated December 28, 2004, Applicants amend the claims as follows and submit the following remarks.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.